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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Naoki YOSHIOKA, et al.

Serial No.: Not Yet Assigned

Filed: September 21, 2001

For: LIQUID SUBSTANCE SUPPLY DEVICE FOR VAPORIZING SYSTEM, VAPORIZER,
AND VAPORIZATION PERFORMANCE APPRAISAL METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

September 21, 2001

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

Copies of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,
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Enclosures: PTO-1449; References (3)



**INFORMATION
DISCLOSURE
STATEMENT
PTO-1449**

Atty. Docket No. **010871**

Serial No. New Appln.

Applicant(s): **Naoki YOSHIOKA, et al.**

Filing Date: **September 21, 2001**

Group Art Unit:

1c979 U.S. PTO
09/21/01
09/21/01

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
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FOREIGN PATENT DOCUMENTS

		AE			
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		Document No.	Date	Country	Translation (Yes or No)
	AF	5-253402	10/05/93	Japan	No.
	AG	11-345774	12/14/99	Japan	Abstract
	AH	WO 94/21840	09/24/94	PCT	
	AI				
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OTHER DOCUMENTS					

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